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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Izumi FUSEGAWA et al.

Group Art Unit: 1722

Application No.: 10/568,186

Docket No.: 126961

Filed: March 3, 2006

For: METHOD FOR PRODUCING A SINGLE CRYSTAL AND SILICON SINGLE  
CRYSTAL WAFER

**REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

William P. Berridge  
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Registration No. 33,565

WPB:MAC/cab

Date: October 19, 2006

**OLIFF & BERRIDGE, PLC**  
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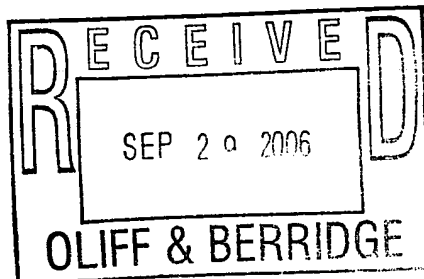
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| APPL NO.   | FILING OR 371<br>(c) DATE | ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
|------------|---------------------------|----------|---------------|-----------------|----------|----------|----------|
| 10/568,186 | 03/03/2006                | 1722     | 1030          | 126961          | 5        | 17       | 2        |

25944  
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CONFIRMATION NO. 5592  
 CORRECTED FILING RECEIPT



\*OC00000020608869\*

Date Mailed: 09/27/2006

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**Applicant(s)**

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 Nobuaki Mitamura, Fukushima, JAPAN;  
 Takahiro Yanagimachi, Fukushima, JAPAN;

mitamura

**Assignment For Published Patent Application**

Shin-Etsu Handotai Co., Ltd., Tokyo, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number 25944.**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP04/11685 08/13/2004

**Foreign Applications**

JAPAN 2003-296837 08/20/2003

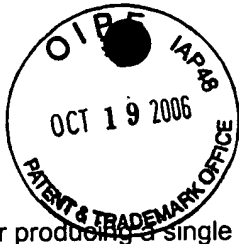
If Required, Foreign Filing License Granted: 07/20/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/568,186**

Projected Publication Date: 10/26/2006

Non-Publication Request: No

Early Publication Request: No

**Title**

Method for producing a single crystal and silicon single crystal wafer

**Preliminary Class**

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